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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

MAEDA et al

Serial No.: 09/808,016

Filed: March 15, 2001

For: FILM-FORMING SURFACE
REFORMING METHOD AND
SEMICONDUCTOR DEVICE
MANUFACTURING METHOD

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) Art Unit: 2829
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) Examiner: Kilday
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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(C)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record Japanese Kokai 11-111714 a copy of which is submitted herewith along with a published English language abstract thereof.

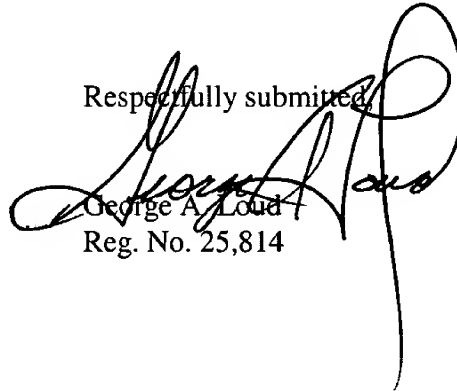
Also submitted herewith is a copy of an office action received in connection with Korean Patent Application 10-2001-0016176 by which Japanese Kokai 11-111714 was brought to applicants' attention. The examiner will note that the date of the Korean office action is May 27, 2003. The aforementioned Korean Patent Application 10-2001-0016176 is believed to correspond to the captioned application.

The second reference cited in the Korean Office Action of May 7, 2003, i.e., Korean Patent Publication 1995-7032 is believed to correspond to U.S. Patent 5,656,337 which is already of record.

CERTIFICATION

The undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,



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Dated: July 28, 2003

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